UNITED STATES PATENT AND TRADEMARK OFFICE CERTIFICATE OF CORRECTION

PATENT NO.

: 6,953,730 B2

DATED

: October 11, 2005

INVENTOR(S) : Ahn et al.

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Title page,

Item 56, References Cited, U.S. PATENT DOCUMENTS, delete

- "Forbes et al." and insert -- Ahn at al. --; delete "428/765" and insert -- 428/698 --. OTHER PUBLICATIONS,
- "Shin, Chang. H. et al." reference, delete "Fabriation" and insert -- Fabrication --.
- "Aarik, Jaan, et al.," reference, delete "doposition" and insert -- deposition -- .
- "De Flaviis, Franco, et al.," reference, delete "Micorwave" and insert -- Microwave --.
- "Kim, Yongjo, et al.," reference, delete "micorwave" and insert -- microwave --.
- "Molodyk, A.A., et al.," reference, after "(2000)," delete "),".
- "Shin, Chang H., et al.," reference, delete "Fabriation" and insert -- Fabrication --.
- "Takemoto, J.H., et al.," reference, delete "Superconducting" and insert
- -- Superconducting --.
- "Yamaguchi, Takeshi, et al.," reference, delete "Fabricated" and insert
- -- Fabricated --.
- "Zhu, W., et al.," reference, delete "Tranport" and insert -- Transport --.
- "Chambers, J J., et al.," reference, delete "yltrium" and insert -- yttrium --.
- "Kukli, K, et al.," reference, delete "porperties" and insert -- properties --.
- "Kukli, K, et al.," (second occurrence), reference, delete "5598" and insert -- 5698 --.
- "Lee, S.J., et al.," reference, delete "Devicea" and insert -- Devices --.
- "Lee, Jung-Hyoung, et al.," reference, delete "Meetings." and insert -- Meeting, --.
- "Poveshchenko, V P., et al.," reference, delete "phas" and insert -- phase --.

Column 10,

Line 64, after "comprising" delete ";" and insert --: --.

Signed and Sealed this

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Twenty-first Day of March, 2006

JON W. DUDAS
Director of the United States Patent and Trademark Office